

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>				
<b>Filing Date:</b>				
<b>Title of Invention:</b>	SUBSTRATE DICING SYSTEM, SUBSTRATE MANUFACTURING APPARATUS, AND SUBSTRATE DICING METHOD			
<b>First Named Inventor:</b>	Yoshitaka Nishio			
<b>Filer:</b>	Shahpar Shahpar/Julie Eslick			
<b>Attorney Docket Number:</b>	49288.2800			
Filed as Small Entity				
<b>U.S. National Stage under 35 USC 371 Filing Fees</b>				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
Basic National Stage Fee	2631	1	150	150
Natl Stage Search Fee - Report provided	2642	1	200	200
Natl Stage Exam Fee - all other cases	2633	1	100	100
<b>Pages:</b>				
Natl Stage Appl Sz fee per 50 pgs >100	2681	2	125	250
<b>Claims:</b>				
Claims in excess of 20	2615	39	25	975
Multiple dependent claims	2616	1	180	180

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
Post-Allowance-and-Post-Issuance:				
<b>Extension-of-Time:</b>				
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>1855</b>